



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **New Patent** Application of)
Shunpei YAMAZAKI et al) Attn: Applications
Japanese Priority No.: 2001-055383) Branch
Japanese Priority Date: February 28, 2001)
For: METHOD OF MANUFACTURING A) Date: February 25, 2002
SEMICONDUCTOR DEVICE)

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23
53-07

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

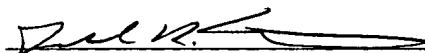
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some or all of the references listed on the attached Form PTO-1449 are discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


Donald R. Studebaker
Registration No. #32,815

Nixon Peabody LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110

DRS/JLC/sas